



REF #
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Docket No.: 057454-0994

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
:
Takeshi SATOH, et al. : Confirmation Number: 3233
:
Application No.: 10/750,870 : Group Art Unit: 1754
:
Filed: January 05, 2004 : Examiner: Edward M. Johnson
:
For: POROUS Si3 N4 AND PRODUCING METHOD THEREOF

PETITION FOR EXTENSION OF TIME

Mail Stop EOT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the Office Action dated October 21, 2005, now due to expire January 21, 2006, be extended for one month(s) and set to expire on February 21, 2006.

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Brian K. Seidleck

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02/23/2006 MDAMTE1 00000055 500417 10750070

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Date: February 21, 2006

Please recognize our Customer No. 20277
as our correspondence address.